Examiner-Initiated Interview Summary	Application No.	Applicant(s)
	10/533,580	KIMURA ET AL.
	Examiner	Art Unit
	Vera Katz	1784
All Participants: Status of Application: <u>Special New</u>		
(1) <i>Vera Katz</i> .	(3) Jeffrey Bousquet, r.n. 57,771.	
(2)	(4)	
Date of Interview: 9 December 2010	Time: <u>10:00 am</u>	
Type of Interview: ☐ Telephonic ☐ Video Conference ☐ Personal (Copy given to: ☐ Applicant ☐ Applicant's representative) Exhibit Shown or Demonstrated: ☐ Yes ☐ No If Yes, provide a brief description:		
Part I.		
Rejection(s) discussed: 102/103		
Claims discussed: 1-2, 13, 24, 27-28, and 43		
Prior art documents discussed: Toki and Lortz		
Part II. SUBSTANCE OF INTERVIEW DESCRIBING THE GENERAL NATURE OF WHAT WAS DISCUSSED: See Continuation Sheet		
Part III.		
It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview directly resulted in the allowance of the application. The examiner will provide a written summary of the substance of the interview in the Notice of Allowability. It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview did not result in resolution of all issues. A brief summary by the examiner appears in Part II above.		
/Jennifer C McNeil/ Supervisory Patent Examiner, Art Unit 1784 /Vera Katz/ Examiner, Art Unit 1784 (A	pplicant/Applicant's Representati	ive Signature – if appropriate)

Continuation of Substance of Interview including description of the general nature of what was discussed: Discussed newly amended claims 1-2, 13 24, 27-28 and 43 now incorporating a negative limitation "no other water is added to a dispersoid". This limitation does not have a required basis in the original disclosure for negative limitation and would be rejected under U.S.C.112, first paragraph (new matter); see MPEP 2173.5(i). To place the application in condition for allowance it was proposed by the Examiner to delete this negative limitation. It was also proposed to cancel the withdrawn claims related to a metal oxide film. It can be done by the Examiner's Amendment. Applicant representative will contact the Applicant to autorize the proposed amendment.